

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

10062952

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10062952	01/31/2002	216	8	1746	Pompl, w

**APPLICANTS: Lee Heon;

**CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO	
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		10007140-1	
Verified and Acknowledged Examiners's initials			

TITLE : Nano-size imprinting stamp using spacer technique

U.S. DEPT. OF COMM./PAT. & TM.-PTO-435L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
TERMINAL		Primary Examiner	
DISCLAIMER		Application Examiner	
		PREPARED F R ISSUE	
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